

Notice of References Cited	Application/Control No. 10/567,626		Applicant(s)/Patent Under Reexamination NENYEI ET AL.	
	Examiner Aaron A. Dehne		Art Unit 2829	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0018684	01-2004	Ji, Hua	438/258
	B	US-			
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	J	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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